

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L4	1	((substrate or semiconductor or wafer) and nozzle and inert and gas and determin\$3 and direction and speed).clm.	US-PGPUB	ADJ	ON	2008/03/04 22:35
L7	22	(dry\$3 and (substrate or semiconductor or wafer) and nozzle and (hole or opening or aperture or perforation) and number).clm.	US-PGPUB	ADJ	ON	2008/03/04 22:39